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APPLICANTS

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** CONTINUING DATA ***** None (U)

** FOREIGN APPLICATIONS ***** YFI (U)
 REPUBLIC OF KOREA 2002-85460 12/27/2002

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 3	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
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TITLE

Method of forming isolation film of semiconductor device

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